

#### **AE** International

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### Mounts All Standard Applications, with Custom Adaptations Available

- 1. Pressure-adjustable roller and platen process virtually any material, even thin or brittle substrates.
- 2. Controlled-temperature platen and tension adjustment bars provide optimal tape application conditions for standard ("blue") and UV curable dicing tape.
- 3. Excess tape accurately and safely trimmed from frame using circular cutter.
- 4. Static eliminator option removes electrical charges from dicing tape. ESD wrist-strap socket grounds operator to protect static sensitive devices during mounting process.
- 5. UV curable dicing tape easily applied using UV tape backing removal option.
- 6. Non-contact chucks (custom-made, per application requirements) available for protecting materials with sensitive surfaces. Non-contact chuck supports wafer edges, while "pillow" of compressed air supports wafer face during tape application.
- 7. Custom features, by request:
  - Special-design chucks for non-standard wafer/frame/tape combinations and applications.
  - Wafer x,y Centering and Theta Alignment options (reduce dicing system alignment setup time).

### MWM-850/MWM-853 Options

- 1. UV tape backing remover ejects UV tape backing from system to facilitate waste material management.
- 2. ESD eliminator ionizer bar eliminates electrostatic charges on mounting tape to protect ESD-sensitive devices.
- 3. Non-contact chuck (custom-manufactured, per application) reduces mechanical contact between chuck and wafer during mounting process to protect sensitive wafer lithography surface.
- 4. Wafer alignment mechanism: x,y centering and Theta alignment (custom manufactured, per application requirements) - centers wafer on wafer frame and provides optical Theta angle adjustment for high repeatability mounting results.
- 5. Custom-designed chuck work surfaces to accommodate specific application requirements.

#### **Technical Specifications**

Model:	MWM-850	MWM-853
Dimensions:	30.5 (H) x 39.5 (W) x 80 cm (D)	30.5 (H) x 53 (W) x 95 cm (D)
	12" (H) x 15.5" (W) x 31.5" (D)	12" (H) x 21" (W) x 37.5" (D)
Weight:	70 lbs (32 kg)	100 lbs (45 kg)
Line Voltage:	110/220 Vac, 50/60 Hz, Single Phase	
Air:	5 bar, CDA	

• All other countries and general enquiries: E-mail: sales@eshal.com



# MWM-850/853 Manual Wafer Mounting Systems

## **General Description**

AE's MWM-850 and MWM-853 systems provide controlled and repeatable wafer-to-frame tape mounting results. Optimal tape tensioning and bubble-free mounting are critical elements for consistent, reliable results in dicing and singulation processing. With their robust and flexible design, AE's manual wafer mounters are multi-purpose wafer mounting platforms, with standard features and options to handle all wafer and film frame sizes up to 12".

### **Robust and Easy-to-Use**

AE's years of experience in the design and manufacture of field-proven wafer mounting systems are the foundation on which the MWM-850 and MWM-853 are built. Simple to set up and operate, these systems are accurate and user-friendly. With their piston-aided cover-lifting mechanism and ergonomic design, operators find the MWM-850 and MWM-853 systems easy-to-use throughout their shift. Robust mechanical design means reliable wafer mounting, day-in and day-out. Requiring only compressed air and electricity, AE's manual wafer mounters can be used almost anywhere space is available.



